

03500.017597.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MASAKI MIZUTANI, et al. ) Examiner: M. J. Song  
Application No.: 10/670,301 ) Group Art Unit: 1722  
Filed: September 26, 2003 )  
For: METHOD FOR GROWING )  
SILICON FILM, METHOD FOR )  
MANUFACTURING SOLAR )  
CELL, SEMICONDUCTOR )  
SUBSTRATE, AND SOLAR )  
CELL : April 13, 2006

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

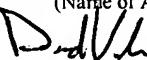
In response to the Office Action dated January 13, 2006, please amend the  
above-identified application, as follows:

04/19/2006 SDENBDB1 00000006 10670301  
01 FC:2203  
Void date: 04/19/2006 SDENBDB1 00000006 10670301  
01 FC:2203 180.00 0P  
-180.00 0P

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to:  
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on

April 13, 2006  
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310  
(Name of Attorney for Applicant)

  
Signature April 13, 2006  
Date of Signature